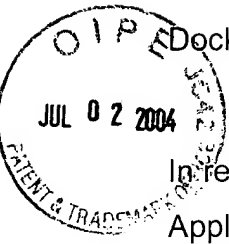


AF  
2623



Docket No. AMDP440USA

E0778

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re **PATENT** application of:

Applicant: Bryan K. Choo et al.

Application No.: 09/642,959

For: OPTIMIZATION OF OPC DESIGN FACTORS UTILIZING AN  
ADVANCED ALGORITHM ON A LOW VOLTAGE CD-SEM  
SYSTEM

Filing Date: August 21, 2000

Examiner: Ryan J. Hesseltine

Art Unit: 2623

**RECEIVED**

JUL 07 2004

Technology Center 2600

**REPLY TO OFFICE ACTION DATED MAY 19, 2004**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully  
requested in view of the following remarks.